



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 4, 2026

IGI Report Number

LG834610807

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

10.58 X 6.66 X 4.38 MM

GRADING RESULTS

Carat Weight

3.02 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

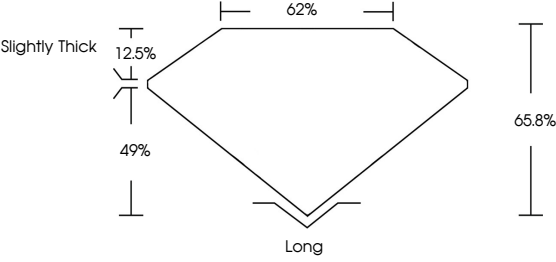
Inscription(s)

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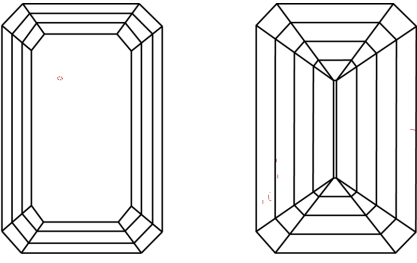
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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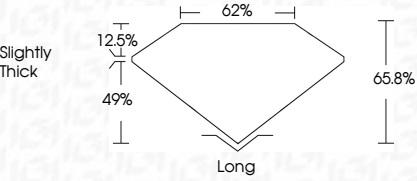
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IGI

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IGI Report No LG834610807
EMERALD CUT

3.02 CARATS
F

10.58 X 6.66 X 4.38 MM

Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle

3.02 CARATS
F
VS 1
65.8%
62%
Slightly Thick

Long
EXCELLENT
EXCELLENT
NONE
IGI LG834610807

Culet
Polish
Symmetry
Fluorescence
Inscription(s)

None
EXCELLENT
EXCELLENT
NONE
IGI LG834610807

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